Micro cantilever

Product name

OTR8-PS-W

Silicon nitride Triangular cantilever with Sharpened Pyramidal tip

Micro Cantilever
OTRS-PS-W
Lot No.
OLYMPUS CORPORATION
OLYMPUS

Made in Japan

<u>OTR8-PS-W</u>

O: OLYMPUS

 $TR: \quad \ Triangular\ cantilever$

8: Lever thickness of 800 nm

P: Pyramidal tip

S: Single side metal coating (reflex coat)

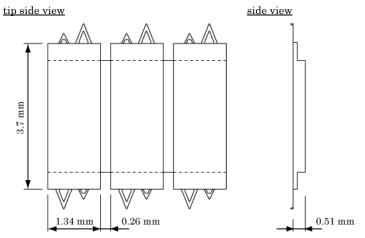
W: Wafer / unit (14 strips / unit)

(490 chips / unit)

Chip

There are two types of triangular cantilevers (100 μm and 200 μm long) on both sides of the glass chip.

Dimensions



Material

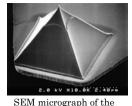
Tip & Lever	Silicon nitride	
Metal coating	Gold / Chromium	
Chip	Pyrex glass	

<u>Tip</u>

The tip is a hollow pyramid with a sharp apex (oxide sharpened).

Dimensions

			Typical value
Ti	ip height	(µm)	2.9
Ti	ip radius	(nm)	< 20
Ti	ip angle	(deg.)	< 70



sharpened pyramidal tip

Tip angle between diagonal ridges is less than 90 degrees.

Cantilever

Dimensions

	Typical value		
Cantilever length L (µm)	100	200	
Cantilever width W (µm)	refer to illust. below		
$\begin{array}{ccc} Cantilever\ thickness \\ & t & (\mu m) \end{array}$	0.8		[unit:micrometer]
Metal coat thickness tm (μm)	0.065 (Reflex)		× ×
	001 = 7	6 	/ - \ -

Calculated mechanical properties

		Typical value
Resonant frequency	100 μm long lever	73
(kHz)	200 μm long lever	24
Spring constant	100 μm long lever	0.57
(N/m)	200 μm long lever	0.15

